

Air-Stable Surface Charge Transfer Doping of MoS₂ by Benzyl Viologen

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Supporting Information

ABSTRACT: Air-stable doping of transition metal dichalcogenides is of fundamental importance to enable a wide range of optoelectronic and electronic devices while exploring their basic material properties. Here we demonstrate the use of benzyl viologen (BV), which has one of the highest reduction potentials of all electron-donor organic compounds, as a surface charge transfer donor for MoS₂ flakes. The n-doped samples exhibit excellent stability in both ambient air and vacuum. Notably, we obtained a high electron sheet density of $\sim 1.2 \times 10^{13} \text{ cm}^{-2}$, which corresponds to the degenerate doping limit for MoS₂. The BV dopant molecules can be reversibly removed by immersion in toluene, providing the ability to control the carrier sheet density as well as selective removal of surface dopants on demand. By BV doping of MoS₂ at the metal junctions, the contact resistances are shown to be reduced by a factor of >3 . As a proof of concept, top-gated field-effect transistors were fabricated with BV-doped n⁺ source/drain contacts self-aligned with respect to the top gate. The device architecture, resembling that of the conventional Si transistors, exhibited excellent switching characteristics with a subthreshold swing of $\sim 77 \text{ mV/decade}$.

Transition metal dichalcogenides (TMDCs) are a promising class of layered semiconductors exhibiting atomically uniform thicknesses with a wide range of band gaps and band alignments.^{1–4} They can be scaled down to a monolayer in thickness, providing a model two-dimensional (2D) material system for exploiting nanoscale phenomena while presenting a promising platform for future electronics and optoelectronics with novel functionalities.^{5–9} As in any semiconductor, controlled chemical doping is essential for modulating the carrier concentrations and electronic properties, thereby enabling fabrication of various homo/heterojunctions and complex devices.^{3,4,10–12} In this regard, surface charge transfer doping of TMDCs, including MoS₂ and WSe₂, has been demonstrated in the past using surface-adsorbed potassium¹² and NO₂¹¹ species as donors and acceptors, respectively. This doping concept is similar to what has been previously exploited for other molecular-scale materials such as organic molecules¹³ and polymers,¹⁴ carbon nanotubes,¹⁵ graphene,¹⁶ and ultrathin III–V membranes.¹⁷ In this approach, by the choice of surface-adsorbed species with proper reduction potentials with respect

to that of the desired semiconductor, either electron donation or electron withdrawal can be induced. Notably, in comparison with conventional substitutional doping, surface charge transfer does not induce defects in the semiconductor lattice. While adsorbed K atoms have been shown to be highly effective in donating electrons to TMDCs for n-type doping, the approach lacks air stability.¹² K atoms vigorously react with ambient air and water molecules, thereby making the process viable only in a high-vacuum environment. In this regard, the development of air-stable dopants for TMDCs is of tremendous interest for further advancement of the field. Here we demonstrate air-stable n-doping of MoS₂ up to the degenerate level using benzyl viologen (BV) as the surface charge transfer donor. BV doping was previously applied to carbon nanostructures, including graphene¹⁸ and nanotubes,¹⁹ demonstrating its stable electron donating characteristics. Here we studied the effectiveness of BV as a donor in few-layer MoS₂ crystals. Electron transfer from the BV molecule to MoS₂ generates an electron transfer complex that is stable under ambient conditions as well as in vacuum, allowing for extensive device and electron transport characterizations as well as facilitating a deeper level of material understanding. As a proof of concept, we show that degenerate n-doping of MoS₂ in the proximity of metal contacts reduces the contact resistance for electron injection by a factor of ~ 3 as a result of thinning of the Schottky barrier (SB). Furthermore, we fabricated high-performance top-gated MoS₂ transistors in which the gate electrode is used as a self-aligned mask to selectively dope the source/drain regions of MoS₂. The resulting n⁺/i/n⁺ devices resemble conventional n-MOSFETs, exhibiting excellent switching characteristics. The present work introduces a highly stable and effective n-doping scheme for MoS₂ based on a hybrid system of synergistically interactive organic molecules and inorganic TMDCs.

The structure of the dopant molecule BV is shown in Figure 1a. BV has one of the lowest reduction potentials among all electron-donor organic molecules,²⁰ making it an optimal choice for use as a donor. The neutral BV molecule (BV⁰) transfers electrons to an acceptor material (in this case, MoS₂), and eventually a two-electron transfer process is carried out to generate an electron transfer complex between the divalent BV molecule (BV²⁺) and a divalent acceptor material (acceptor²⁻ state). The energy diagram shown in Figure 1c depicts the

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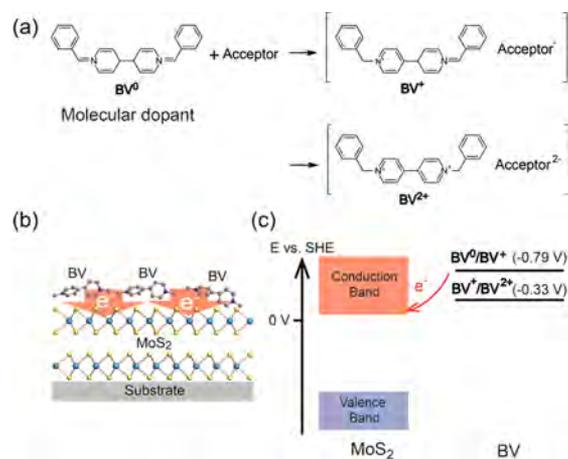


Figure 1. (a) Redox reactions of the BV molecule when it is adsorbed on an acceptor material (in this case, MoS₂). (b) Schematic illustration of BV surface doping of MoS₂. The phenyl rings have been omitted from the schematics of BV molecules for simplification. Color code: C (gray), N (dark blue), Mo (light blue), S (yellow). (c) Energy band diagram of MoS₂ and BV redox states. The conduction band edge of MoS₂ is located at ~0 V vs SHE, which is lower than the redox potentials of the BV molecules. This energy level offset results in electron donation from BV molecules to MoS₂.

expected energy level offset between the conduction band edge of MoS₂ and the reduction potential of the BV molecule. It has been reported in the literature that MoS₂ has a conduction band edge at around 0 V vs the standard hydrogen electrode (SHE),^{5,21,22} while the reduction potentials of the BV molecule are -0.79 V (BV⁰/BV⁺) and -0.33 V (BV⁺/BV²⁺).¹⁹ Because of this energy level offset, MoS₂ acts as an electron-acceptor material, and the BV⁰ molecule can readily transfer electrons to MoS₂.

The charge transfer between BV and MoS₂ was experimentally probed through electrical measurements and Raman spectroscopy. For electron characterization, a wide range of device test structures were fabricated. First, back-gated MoS₂ field-effect transistors (FETs) were fabricated (Figure 2a), and the electrical properties were measured before and after BV doping. The back-gated devices were fabricated with standard lithographic techniques using mechanically exfoliated few-layer MoS₂. The MoS₂ was mechanically exfoliated onto a heavily doped (p⁺) 260 nm thick Si/SiO₂ substrate, which acted as the global back gate, and 30/30 nm Ni/Au metal stacks were used for the source (S)/drain (D) contacts. A yellow solution of BV in toluene (1–5 mg/mL) was synthesized. The sample was then immersed into the BV solution for 12 h and then dried using N₂ gas [see the Supporting Information (SI) for details]. The transfer characteristics of a representative trilayer MoS₂ device are shown in Figure 2b. The as-made FET showed a strong gate dependence with an on/off current ratio of ~10⁵ for applied gate voltages (V_{GS}) ranging from -40 to 40 V and an on-current (I_{DS}) level of ~2 × 10⁻⁵ A at a source–drain voltage (V_{DS}) of 1 V (Figure 2b). After doping with the BV molecule, the characteristic curve changed drastically. The gate dependence of the current was nearly diminished for the same V_{GS} range and the on-current level was increased by an order of magnitude ($I_{DS} = 1.3 \times 10^{-4}$ A at $V_{GS} = 40$ V). The lack of gate dependence and the enhanced current density indicate that the MoS₂ was strongly doped by the BV molecules. The 2D sheet density of electrons in MoS₂ can be extracted as $n_{2D} = (I_{DS}L)/$

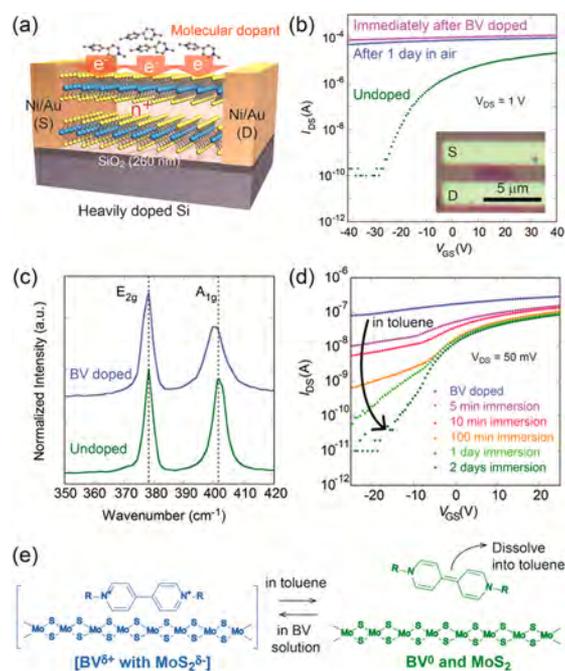


Figure 2. (a) Schematic illustration of a back-gated MoS₂ device used for BV surface charge transfer doping studies. The phenyl rings have been omitted in the schematics of BV molecules for simplification. (b) Transfer characteristic curves of the device before doping (green), right after BV doping (purple), and after the doped device was kept in air for 1 day (blue) at $V_{DS} = 1$ V. The inset shows an optical microscope image of the device, consisting of trilayer MoS₂. (c) Raman spectra of a trilayer MoS₂ flake before (undoped, green curve) and after BV doping (BV-doped, blue curve). The spectra are normalized to the E_{2g} peaks. (d) Transfer characteristics of a BV-doped device as a function of time of immersion in toluene, depicting the on-demand removal of BV surface dopants. As the BV molecules were dissolved away in toluene, the I_{DS} – V_{GS} curves were converted back to the original characteristic profile. (e) Schematic illustration of the desorption/adsorption of BV molecules from/onto the MoS₂ surface through immersion in neat toluene/BV-containing toluene solution, respectively.

($qWV_{DS}\mu$), where L and W are the channel length and width, respectively, q is the electron charge, and μ is the field-effect mobility. The electron mobility at $V_{DS} = 50$ mV was calculated as $\mu = G_m L / (V_{DS} C_{ox} W)$, where $C_{ox} = 1.33 \times 10^{-8}$ F/cm² is the gate oxide capacitance obtained from the parallel plate model and $G_m = dI_{DS}/dV_{GS}$ is the transconductance. The extracted values of μ and n_{2D} are 24.7 cm² V⁻¹ s⁻¹ and 1.2×10^{13} cm⁻², respectively. The extracted n_{2D} is high and corresponds to the degenerate limit. It is similar to the previously reported value of ~10¹³ cm⁻² obtained for MoS₂ via doping with K,¹² which is a high-redox alkali metal ion (the K/K⁺ reduction potential is -2.93 V vs SHE).²³ Notably, the BV-doped device was highly stable in ambient air with only a minimal change in the transfer characteristics over time, even after 9 days of air exposure (Figure 2b and Figure S1 in the SI). This is in contrast to the K-doped samples, which require preparation and measurements in situ under high vacuum since exposure to air causes immediate oxidation of K.^{12,23}

The doped samples were also characterized by Raman spectroscopy (Figure 2c). The original Raman spectrum (before doping with BV) shows lateral (E_{2g}) and vertical (A_{1g}) vibration modes of MoS₂ around 378 and 402 cm⁻¹, respectively. After doping with BV, the A_{1g} peak shifted to a

lower wavenumber as a result of the softening of A_{1g} vibrations at high electron concentrations.²⁴ Furthermore, the full width at half maximum (fwhm) of the A_{1g} peak showed broadening from 5.2 to 8.2 cm^{-1} . On the other hand, the E_{2g} peak remained unchanged. These spectroscopic observations are comparable to those in a previous report of electrostatic doping of MoS_2 by a back-gate potential, where the electron–phonon coupling of the A_{1g} mode was suggested to be stronger than that of the E_{2g} mode.²⁴

Uniquely, the BV dopants could be reversibly removed from the surface of MoS_2 by immersion in toluene. After immersion into toluene, the current level decreased monotonically over time and the gate dependence of the channel gradually reappeared; eventually, the curve returned to the original (before doping) state (Figure 2d and Figure S1). As mentioned before, the BV molecule and MoS_2 form an air-stable electron transfer complex (Figure 2e). When the doped sample was immersed in toluene, the dopant molecules gradually desorbed from the surface and dissolved in toluene, and the device properties of the MoS_2 FET were converted back to those of the original state. This presents a unique feature of surface charge transfer doping compared with conventional substitutional doping. Here, the dopants can be selectively removed by using proper solvents, which in principle presents one pathway toward patterned doping where only a section of the surface dopants are removed by using a lithographic mask. Furthermore, the 2D electron density (corresponding to the dopant concentration) can be readily tuned through the time of immersion in toluene (Figure 2d).

To quantify the effect of MoS_2 doping on the metal– MoS_2 junction properties, we extracted the contact resistance using the transfer line method (TLM) before and after doping by BV. Five metal lines were fabricated in a parallel manner along a 5 nm thick MoS_2 flake to make four devices with different channel lengths ($L_1 < L_2 < L_3 < L_4$; Figure 3a,b). The transfer

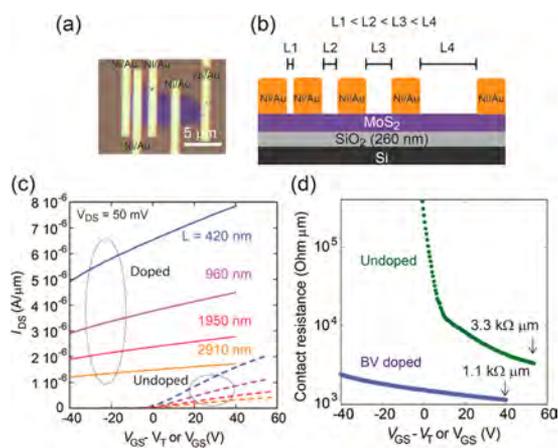


Figure 3. (a) Optical microscope image and (b) schematic of multiple channel length devices fabricated on a single MoS_2 flake to extract the contact resistance using the transmission line model. The flake thickness was ~ 5 nm. (c) Transfer characteristic curves of the devices with different channel lengths before (dashed lines) and after (solid lines) BV doping. The data for the device before doping (dashed line) are plotted vs $V_{GS} - V_T$ ($V_T = -12$ V); on the other hand, the data for the device after the doping are plotted vs V_{GS} . Channel lengths are labeled (420, 960, 1950, and 2910 nm), and the drain voltage used was $V_{DS} = 0.05$ V. (d) Gate-voltage dependence of the measured contact resistance before (green curve) and after (blue curve) BV doping.

characteristic curves at $V_{DS} = 50$ mV for the MoS_2 FETs with L ranging from 420 to 2910 nm are shown in Figure 3c. Before BV doping, all of the devices showed large gate dependence with threshold voltages (V_T) of about -12 V. After BV doping, the on current increased and the gate dependence was minimal, as previously observed for the device in Figure 2. The estimated total resistance (R_{total}) corresponds to the sum of the resistances from the channel ($R_{channel}$) and the contacts (R_c), represented as $R_{total} = R_{channel} + 2R_c$. $R_{channel}$ is proportional to the channel length, and thus, $R_{total} = 2R_c$ at $L = 0$. From the y intercept of the plot of R_{total} versus L , we can extract the contact resistance R_c for a given gate voltage (Figure S2). Figure 3d depicts the gate-voltage dependences of R_c extracted from the TLM method both with and without BV doping. The R_c values after the BV doping ($1.1 \text{ k}\Omega \mu\text{m}$ at $V_{GS} = 40$ V and $1.5 \text{ k}\Omega \mu\text{m}$ at $V_{GS} = 0$ V) are a factor of about 3 smaller than that for the original undoped sample at high gate fields ($3.3 \text{ k}\Omega \mu\text{m}$ at $V_{GS} - V_T = 53.6$ V) and reduced by a factor of >100 at low gate fields (e.g., $V_{GS} = 0$ V). The reduced contact resistance arises from the SB thinning induced by chemical doping to the degenerate limit, enabling a much higher tunneling current to pass directly through the barrier. This effect was further highlighted by temperature-dependent electrical measurements, where a monotonic increase in the on-current level with decreasing temperature was observed for a BV-doped sample (see Figure S4). Thus, the current in our device was limited by phonon scattering in the MoS_2 channel, which has an inverse relationship to temperature, again demonstrating the formation of Ohmic contacts and dominating tunneling current injection without thermionic emission of charge carriers at the metal contact.^{25,26} These results clearly demonstrate the effectiveness of BV doping of MoS_2 and its use in reducing the contact resistance, which often limits the device performance of TMDCs.

Next, we fabricated a top-gated MoS_2 transistor with underlapped metal contacts (Figures 4a,b and S5). The device had a gate length and width of ~ 1.7 and $2.0 \mu\text{m}$, respectively. Ni/Au (30/30 nm) metal contacts were used for S/D with Au as the gate electrode and $\text{SiO}_x/\text{ZrO}_2$ (1/20 nm) as the gate oxide. The underlapped areas between the top gate and S/D metal contacts (with underlap lengths of 400 and 160 nm on the left and right sides, respectively) were degenerately doped to n^+ using BV molecules to reduce R_c , while the channel masked by the gate remained undoped (i). The gate effectively acted as a self-aligned mask for the fabrication of n^+ contact regions. After BV doping of the top-gated device, the on/off current ratio increased from $\sim 10^4$ to $\sim 10^6$ and the on-current level increased by more than 5 orders of magnitude at $V_{DS} = 50$ mV (with an increase of more than 2 orders of magnitude at $V_{DS} = 1$ V; Figure 4c). The subthreshold swing was estimated to be 77 mV/decade after BV doping, which approaches the theoretical limit of 60 mV/decade. The extracted electron mobility was $\sim 20 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$, which is in the same range as those previously reported for MoS_2 top-gated FETs.¹² The output characteristic curves after BV doping also indicated the small contact resistance of the device (Figures 4d and S5). Furthermore, the environmental stability of this top-gated device was confirmed (Figure S6). These top-gate device results demonstrate the ability to pattern-dope MoS_2 using a room-temperature process, which is needed to enable a wide range of junction-based devices.

To summarize, we have demonstrated highly robust n -doping of MoS_2 crystals with excellent stability in ambient air

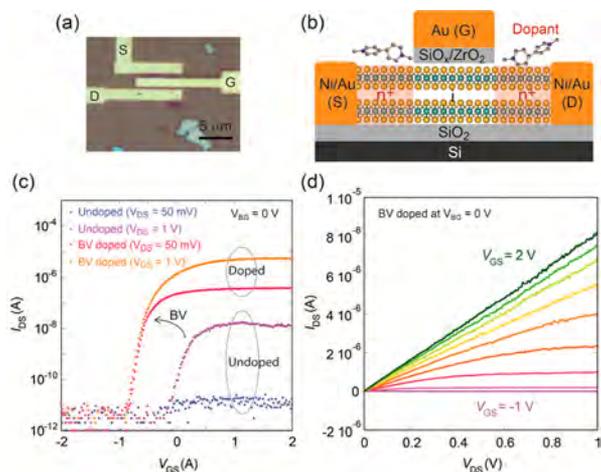


Figure 4. (a) Optical microscope image and (b) schematic of a top-gated MoS₂ device with underlapped regions on each side of the gate. These underlapped regions were doped with BV molecules for the formation of n⁺ source/drain contacts, self-aligned with respect to the gate. The device was fabricated from a trilayer MoS₂ flake. (c) Transfer characteristic curves of the top-gate device before (blue and purple) and after (pink and orange) BV treatment at V_{DS} = 50 mV and 1 V. The substrate was grounded during the measurements. (d) Output characteristics of the device after BV doping measured at gate voltage increments of 0.3 V.

and vacuum by using BV, a high-reduction-potential molecule, as the surface charge transfer dopant. The key doping mechanism is surface charge transfer between the dopant BV molecule and MoS₂ to form an electron transfer complex that is air-stable. The BV molecule was able to dope MoS₂ to a high sheet electron density of $1.2 \times 10^{13} \text{ cm}^{-2}$, which we further explored by fabricating a wide range of different transistor structures. In view of the importance of doping control and dopant profiling of semiconductors for exploring various electronic and optoelectronic devices, the ability to pattern-dope TMDCs through an air-stable process presents an important advance in the field that could facilitate probing the intrinsic transport properties of these 2D semiconductors while exploring novel device architectures.

■ ASSOCIATED CONTENT

Supporting Information

Preparation of the BV solution, fabrication and characterization of the devices, temperature dependence of the transfer characteristics, and additional references. This material is available free of charge via the Internet at <http://pubs.acs.org>.

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Notes

The authors declare no competing financial interest.

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